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AMENDMENT TRANSMITTAL LETTER

Docket No.
FIS920030286US1

Application No.
10/605,889

Filing Date
11/04/2003

Examiner
Long Pham

Art Unit
2814

Applicant(s): Michael P. Belyansky, Jr. et al.

Invention: **OXIDATION METHOD FOR ALTERING A FILM STRUCTURE AND CMOS STRUCTURE FORMED THEREWITH**

TO THE COMMISSIONER FOR PATENTS

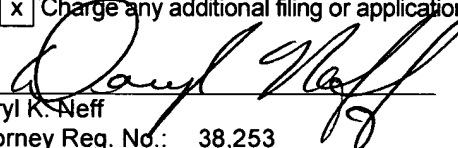
Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

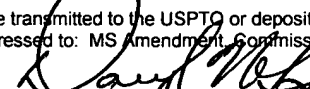
CLAIMS AS AMENDED

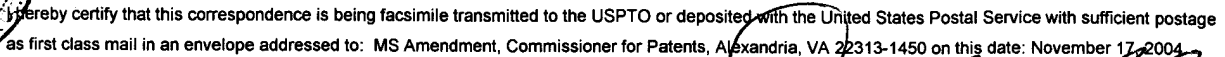
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	21	21	0		
Independent Claims	3	- 3	0		
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					

- ☒ Large Entity ☐ Small Entity
- ☐ No additional fee is required for this amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of \$ _____
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of \$ _____ to cover the filing fee is enclosed.
- ☐ Payment by credit card. Form PTO-2038 is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 09-0458
as described below. A duplicate copy of this sheet is enclosed.
- ☒ Credit any overpayment.
- ☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.


Daryl K. Neff
Attorney Reg. No.: 38,253

Dated: November 17, 2004

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.
Dated: November 17, 2004 Signature:  (Daryl K. Neff)



Signature

In re application of:
Michael P. Belyansky, et al.

Date: November 17, 2004

Serial Number: 10/605,889

Examiner: Long Pham

Filed: November 4, 2003

Group Art Unit: **2814**

Title: OXIDATION METHOD FOR ALTERING A FILM STRUCTURE AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH

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**MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

In response to the Office Action dated August 17, 2004, Applicants submit the following amendments and remarks.

FIS920030286US1